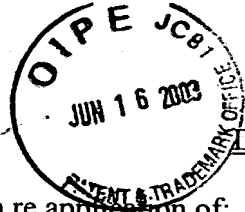


1763

PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Robert A. SHEPHERD, Jr. et al.

Application No. 10/006,100

Filed: December 3, 2001

For: METHOD AND APPARATUS FOR PLASMA
OPTIMIZATION IN WAFER PROCESSING

) Attorney Docket No. NOVEP015

) Examiner: Zervignon, Rudy

) Group Art Unit: 1763

) Date: June 12, 2003

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, Alexandria, VA 22313-1450 on June 12, 2003.

Signed:

Diane Schwanbeck

Commissioner for Patents
Alexandria, VA 22313-1450

Sir:

Applicants hereby transmit an Amendment in the above-identified application.

The fee has been calculated as shown below.

	Claims Remaining After Amendment	Highest Previously Paid For	Present Extra	SMALL ENTITY RATE FEE	OR	LARGE ENTITY RATE FEE
TOTAL CLAIMS	23 -	23	00	X09 = \$	OR	X18 = \$
INDEP CLAIMS	03 -	03	00	X42 = \$	OR	X84 = \$

[] Multiple Dependent Claim Present
and Fee Not Previously Paid

\$140

\$280

TOTAL

\$

\$0

☐
☒

Applicants hereby petition for a ____-month extension of time to respond to the Office Action. Applicants believe that no extension of time is required; however, if it is determined that such an extension is required, Applicants hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an extension of time under 37 CFR 1.136 to Deposit Account No. 50-0805 (Order No. NOVEP015).

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Enclosed is our Check No. ____ in the amount of \$ ____ to cover the extension of time fees. If any fees are required to facilitate filing the enclosed response, please charge such fees to Deposit Account No. 50-0805 (Order No. NOVEP015). A copy of this sheet is enclosed.

Respectfully submitted,
MARTINE & PENILLA, LLP

Edmund H. Mizumoto, Esq.
Registration No. 46,938

710 Lakeway Drive, Suite 170
Sunnyvale, CA 94085
Telephone: (408) 749-6900
Customer No. 25920



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Group Art Unit: 1763

Examiner: Zervigon, Rudy

Atty. Docket No. NOVEP015

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#6A

6/23/03
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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450 on **June 12, 2003.**

Signed:

Diane Schwanbeck
Diane Schwanbeck

AMENDMENT

Commissioner for Patents
Alexandria, VA 22313-1450

Sir:

This paper is in response to the Office Action dated March 12, 2003, the shortened period for response extends to **June 12, 2003.** Please enter the amendments and remarks as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 8 of this paper.